

<b>Notice of References Cited</b>	Application/Control No. 10/620,543	Applicant(s)/Patent Under Reexamination TAKAHASHI ET AL.	
	Examiner David W. Scheuermann	Art Unit 2834	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,243,245	09-1993	Oba, Hiroshi	310/89
	B	US-4,893,043	01-1990	Baines, Roger F.	310/239
	C	US-4,853,576	08-1989	Mayumi et al.	310/239
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 53072108 A	06-1978	Japan	NOTO et al.	H02K 23/04
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

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